

Notice of References Cited	Application/Control No. 10/775,890	Applicant(s)/Patent Under Reexamination SUR ET AL.	
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	C	US-6,107,122	08-2000	Wood et al.	438/117
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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